



TFW

PATENT

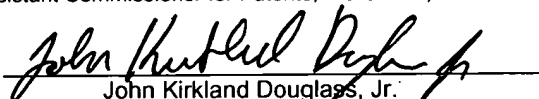
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named Applicant: Ritter
Serial No.: 10/809,624
Filed: 03.25.04
Title: Non-Uniformly Polished Scintillation Crystal For A
Gamma Camera

Docket No.: 2004P02001 US
Examiner: To Be Assigned
Group Art Unit: To Be Assigned
Dated: 07.Jun.2004

CERTIFICATE OF MAILING

I hereby certify that correspondence is being deposited on
07.Jun.2004 with the U.S. Postal Service with sufficient postage as
first class mail on the below-indicated date in an envelope addressed
to: Assistant Commissioner for Patents, Alexandria, VA 22313-1450


John Kirkland Douglass, Jr.

Mail Stop PGPUB
Commissioner for Patents
P.O.Box 1450
Alexandria, VA 22313-1450

LETTER TO OFFICIAL DRAFTSPERSON

Sir:

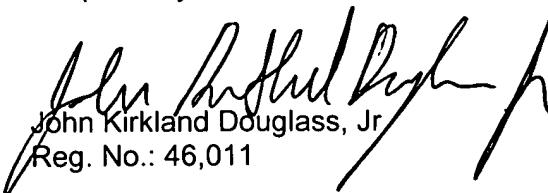
Pursuant to M.P.E.P. Section 608.02, enclosed please find 4 sheet(s) of formal drawings in the referenced case. These are formal versions of the informal drawings filed with the application.

The following applies hereto:

- ☒ No change has been made to the drawing(s) during the prosecution of this case.
- ☐ Change(s) approved by the Examiner in the Notice of Allowability have been incorporated herein.
- ☐ Corrections made herein are informalities noted by the Draftsman on Form PTO-948.
- ☐ Reference is made to the Office Action/Notice of Allowability dated

Passage of this case to issue is respectfully requested.

Respectfully submitted,


John Kirkland Douglass, Jr.
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2004P02001US

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FIG. 1
(PRIOR ART)

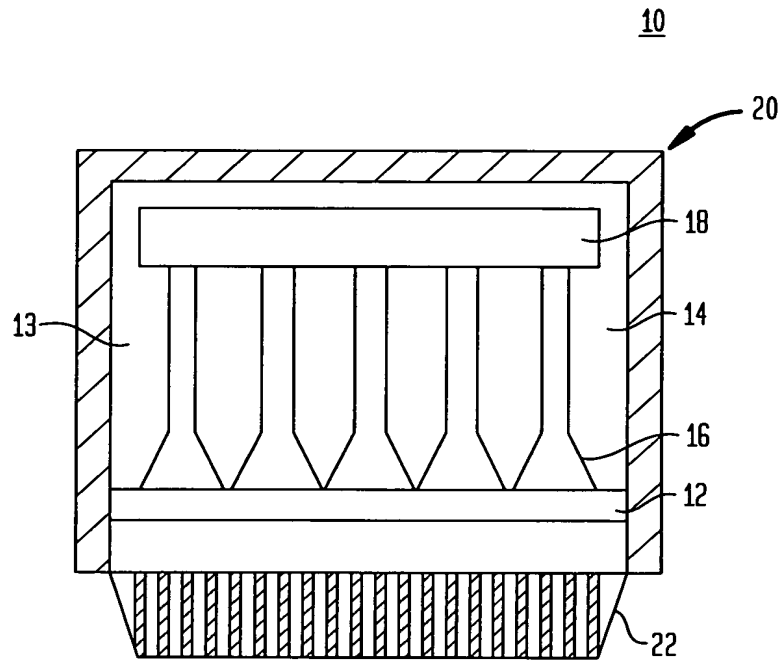


FIG. 2
(PRIOR ART)

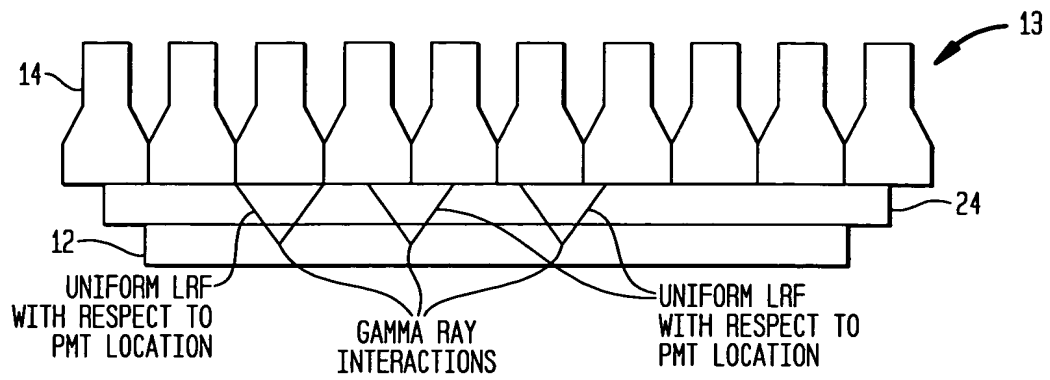


FIG. 4

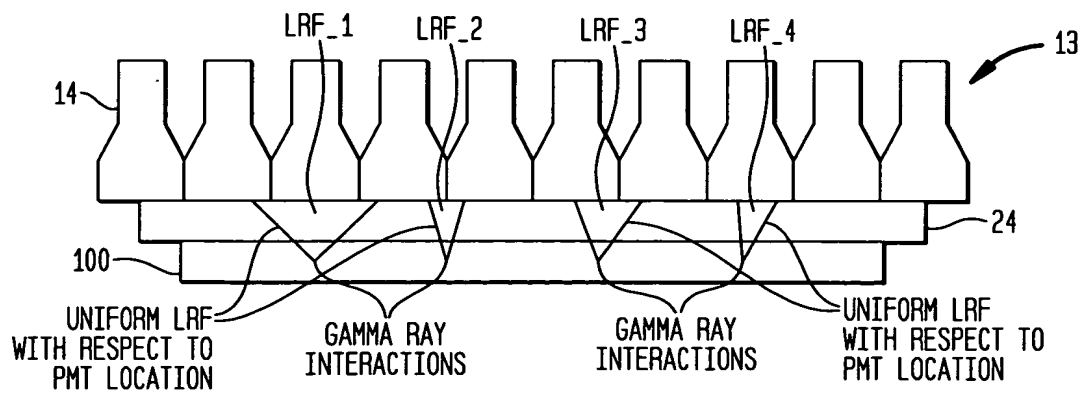


FIG. 3

100

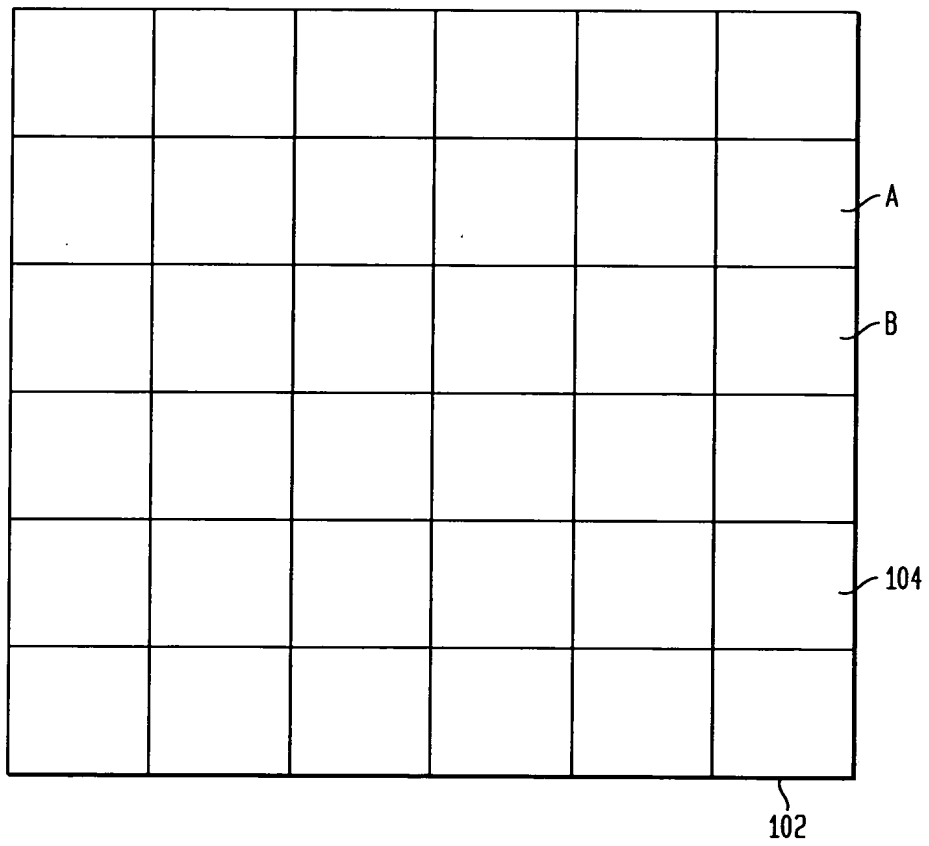


FIG. 5

